

Impact of low-dose electron irradiation on the charge collection of n+p silicon strip sensors

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for the

CMS Tracker Collaboration

in close collaboration with

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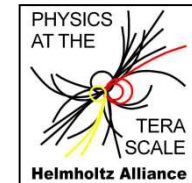


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Introduction

- **Silicon detectors:** The central detectors of most collider experiments
- **Silicon detectors** have shown extraordinary performance
! no Si = no Higgs, no precision top-, b-physics, and more !
- The **HL-LHC** (High-Luminosity LHC) upgrade poses extraordinary challenges
 - **Track densities**
 - **Hadron fluences** ($10^{16} n_{eq}/\text{cm}^2$)
 - **Surface damage** (MGy's in SiO_2)
- **ATLAS** and **CMS** have decided on n^+p sensors and binary readout for **tracker**
- Decision for **pixels** progressing



This work: Study effects of low-dose irradiations by a β -source on the charge collection properties of non-irradiated and irradiated n^+p sensors + discuss relevance for HL-LHC upgrade

Sensors investigated

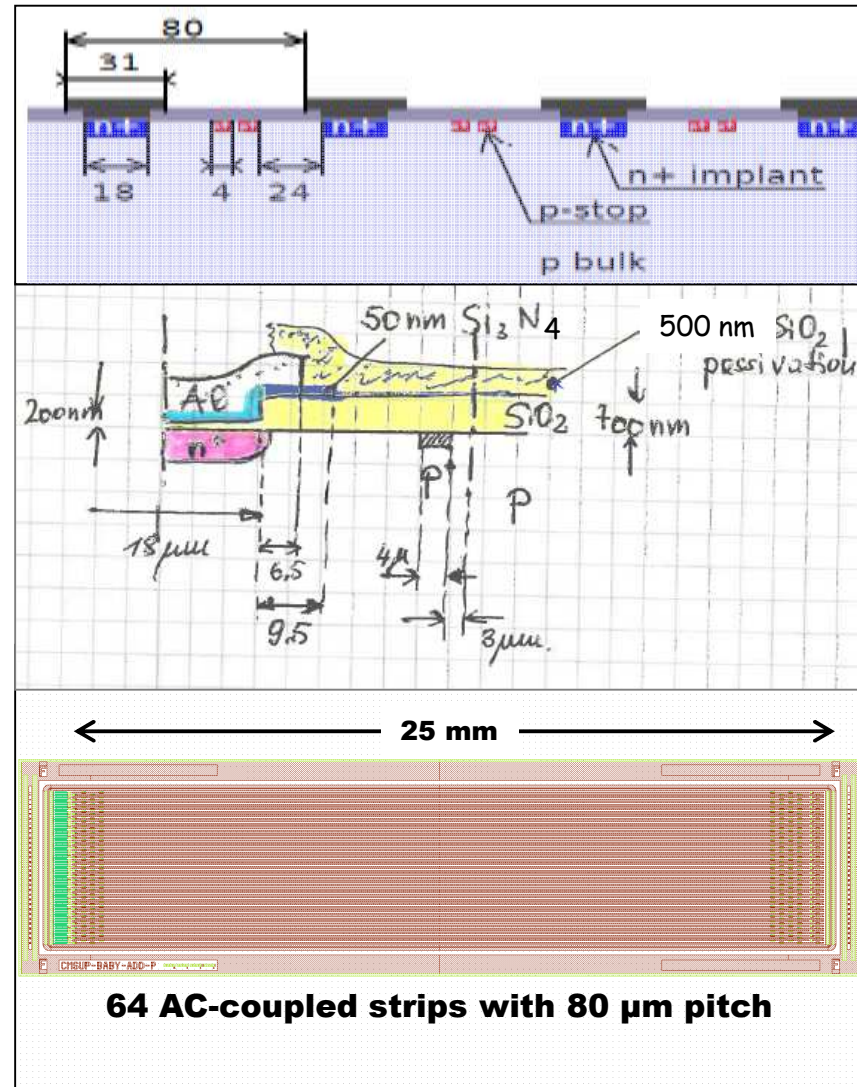
“Baby add. from HPKCampaign”

- FZ p-doping: $3.7 \cdot 10^{12} \text{ cm}^{-3}$
- [O]: $\sim 5 \cdot 10^{16} \text{ cm}^{-3}$
- p-spray: $\sim 5 \cdot 10^{10} \text{ cm}^{-2}$
- p-stop: $\sim 2 \cdot 10^{11} \text{ cm}^{-2}$
- 64 AC-coupled strips
- Strip length: 25 mm
- Pitch: $80 \mu\text{m}$
- Implant width: $19 \mu\text{m}$
- Al overhang: $5 \mu\text{m}$
- d_{Si} : $200 \mu\text{m}$
- d_{SiO_2} : $650 \text{ nm} + 130 \text{ nm}$
- $d_{\text{Si}_3\text{N}_4}$: 50 nm

Irradiations:

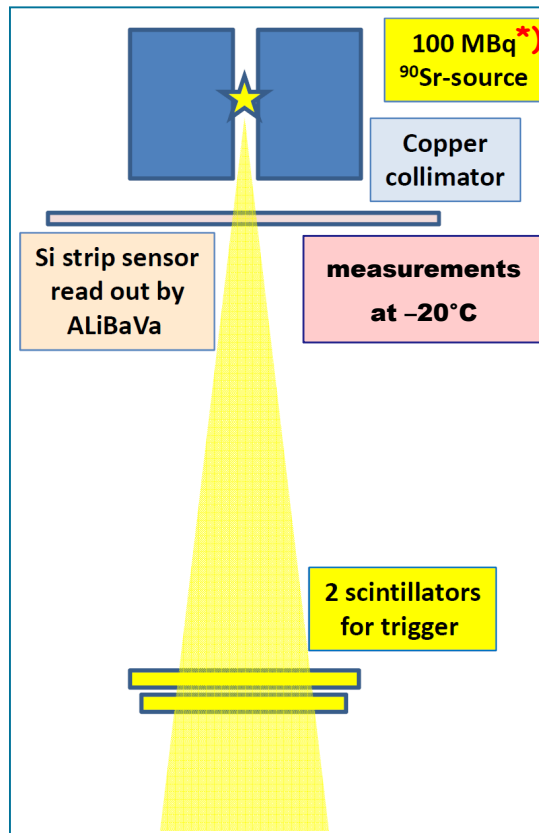
- No irradiation
- Irradiation [cm^{-2}]:
23 GeV protons $15 \cdot 10^{14}$ 1MeV neq +
reactor neutrons $6 \cdot 10^{14}$ 1MeV neq
 → $r \sim 15 \text{ cm}$ for 3000 fb^{-1} HL-LHC
 (→ $\sim 750 \text{ kGy}$ ionizing dose in SiO_2)

Details of sensor layout (p-stop):



Measurement setup + dose rates

Layout, readout + e-irradiation



Energy spectra for electrons and γ 's from ^{90}Sr in SiO_2

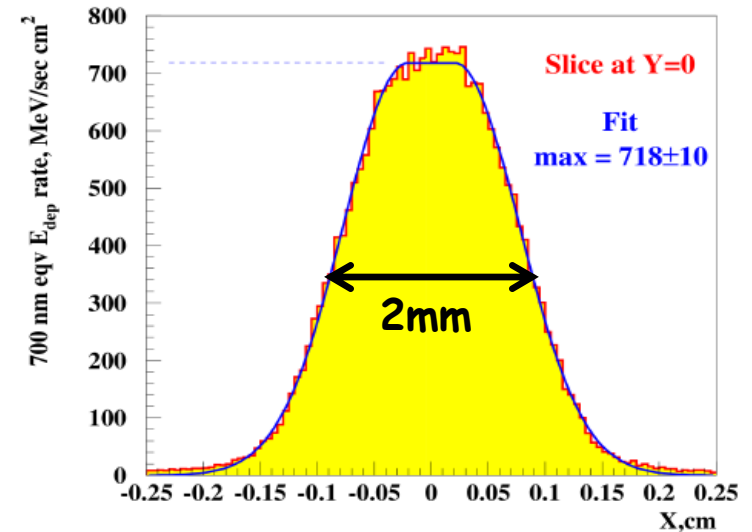
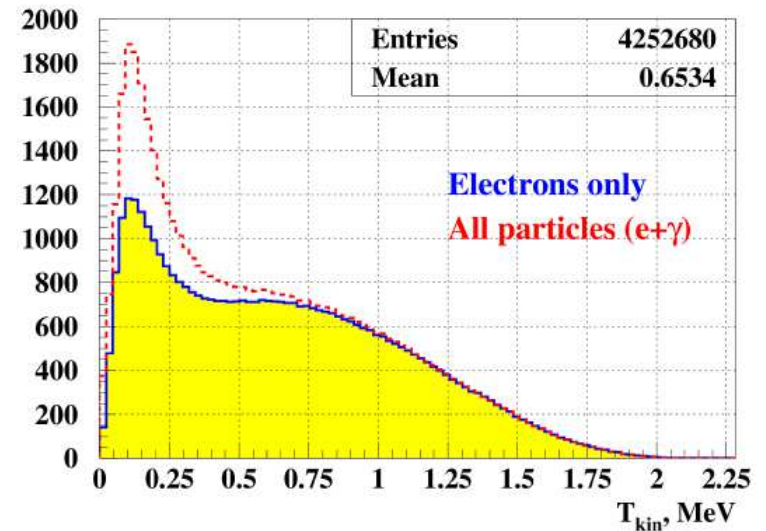
Rate:

- SiO_2 : 50 Gy/day (0(2%) HL-LHC)
- Si-bulk: 10^8 neq/($\text{cm}^2 \cdot \text{day}$)

Width: ~2 mm

Proj. angular spread: ± 100 mrad ($\pm 20\mu\text{m}$ for $200\mu\text{m}$)

dE/dx for trigger e:
Landau mpv= 56keV (54keV for mip)



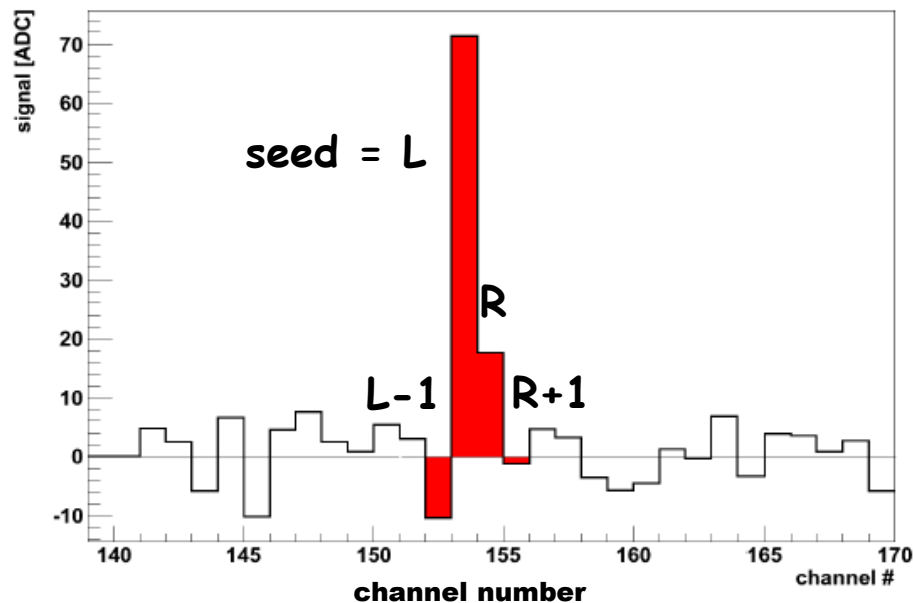
^{*)} Measurements also with 37 MBq ^{90}Sr source

Compared to HL-LHC (or XFEL) very low local doses and dose rates

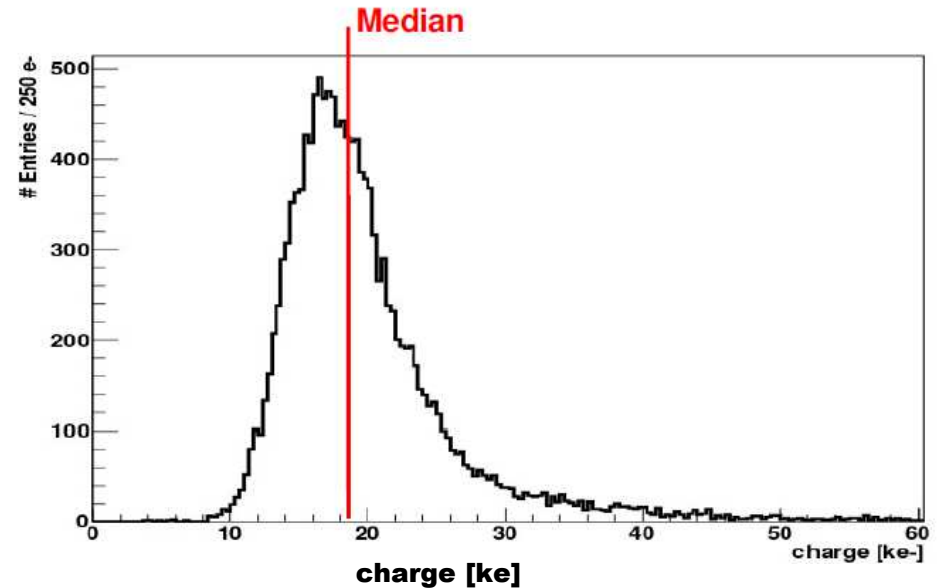
Analysis

- Select events ± 5 ns in phase with 40 MHz clock
- **Seed**: biggest signal in event
- **4 signal strips**: L-1, L, R, R+1
- **4-cluster PH**: Σ (4 signal strips)

Strip pulse heights for single event



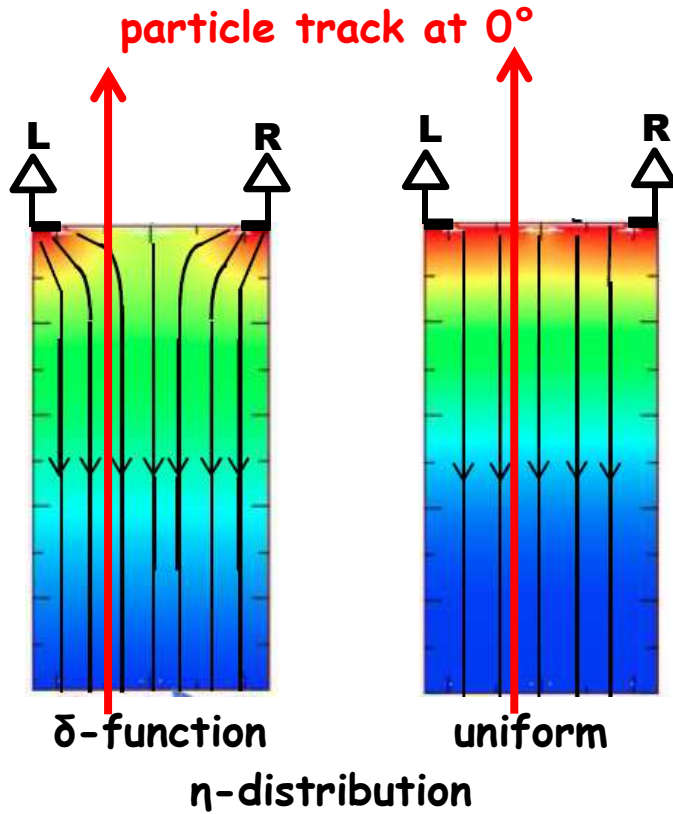
4-cluster pulse height for 5000 events



Comment: As individual pulse height distributions \neq Landau distributions, we prefer to use **median**; statistical uncertainty similar to **Gauss \times Landau fits**, however sensitive to noise pulses!

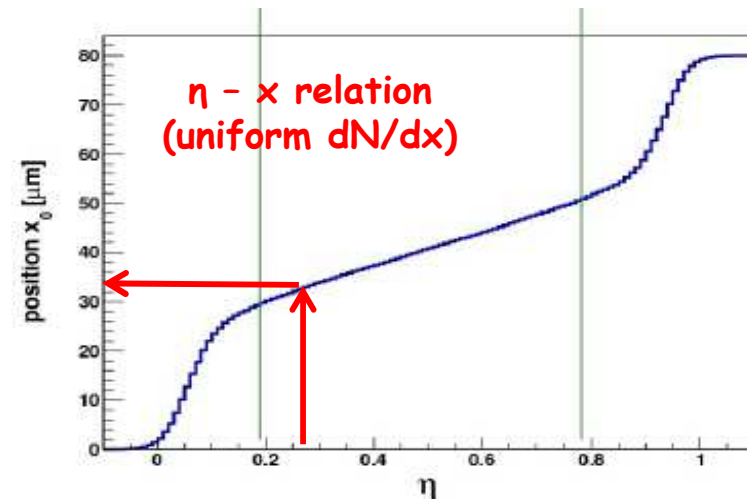
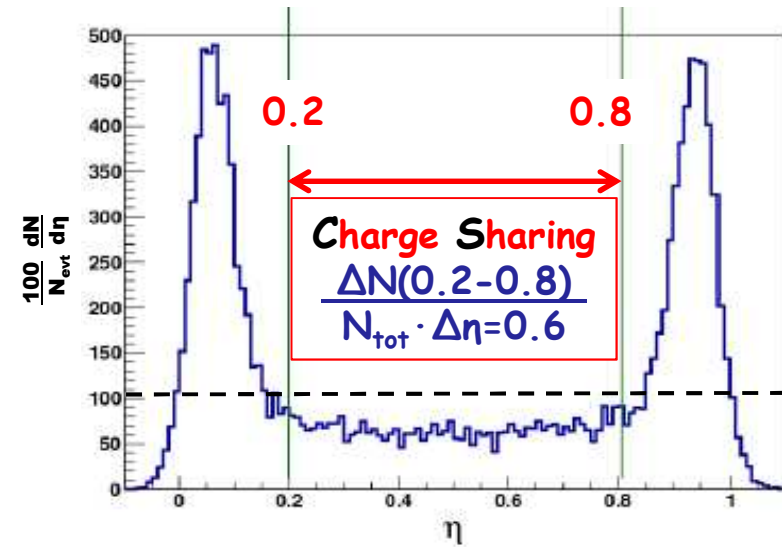
Analysis

Charge sharing: $\eta = \frac{PH(R)}{PH(L) + PH(R)}$ *)



$CS \ll 1$

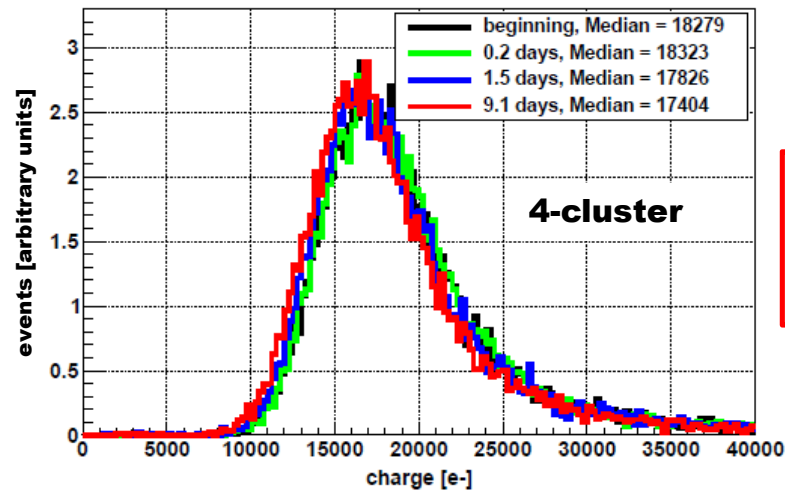
$CS = 100\%$



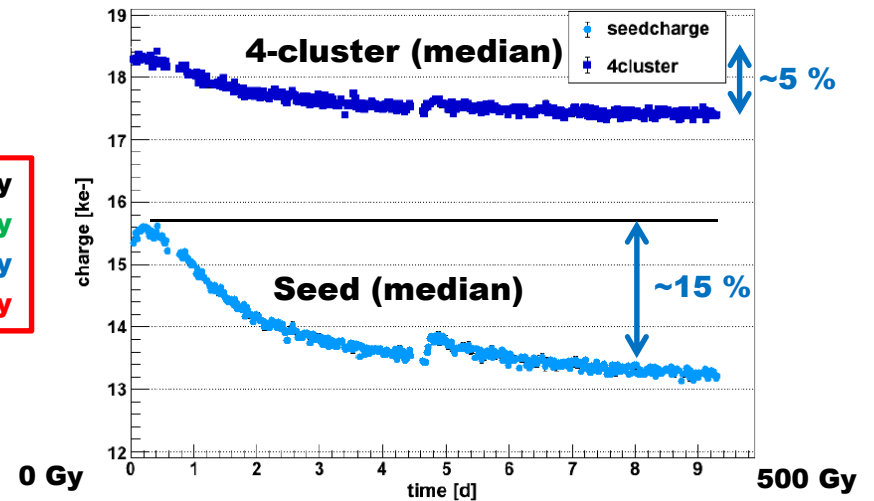
*) E.Belau et al., NIM 214 (1983) 253

η -distribution -> Information on E-field + particle track position

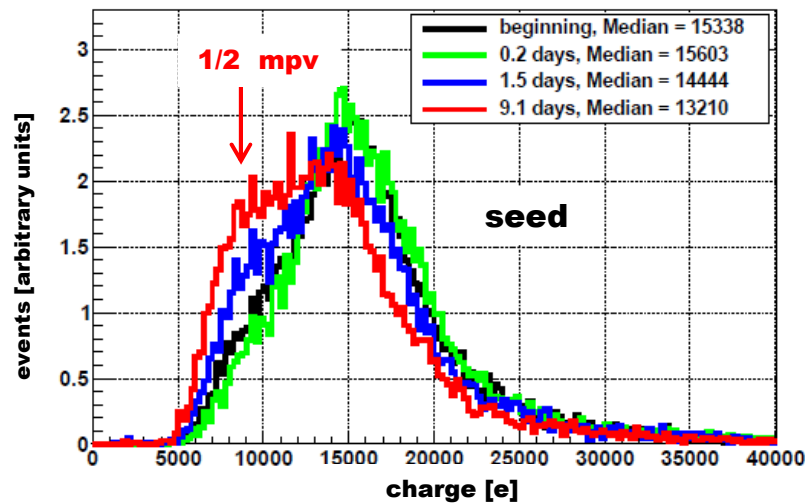
Observations for $V_{bias} = 600$ V (non irr. p-stop sensor)



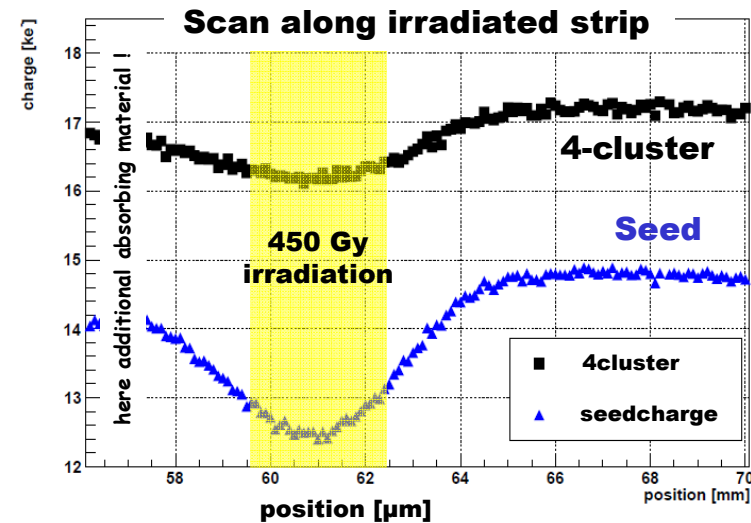
Little change in 4-cluster distribution



Decrease in PH(seed) and PH(4-cluster)

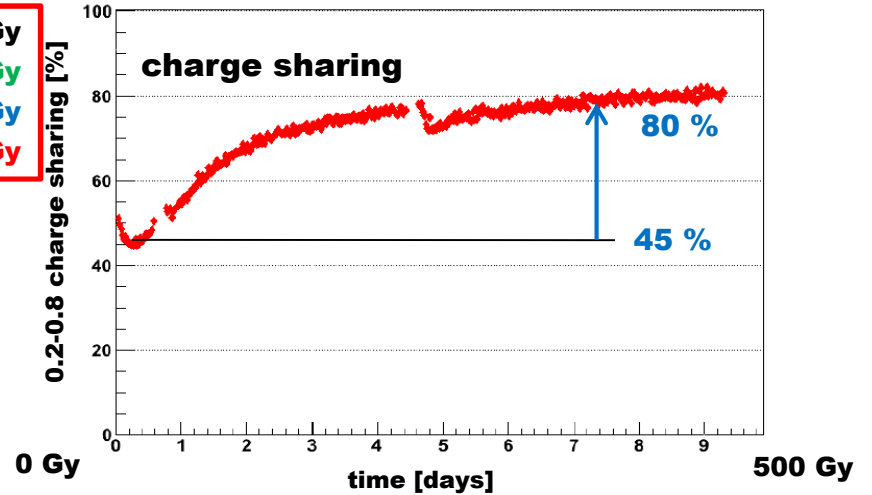
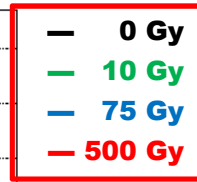
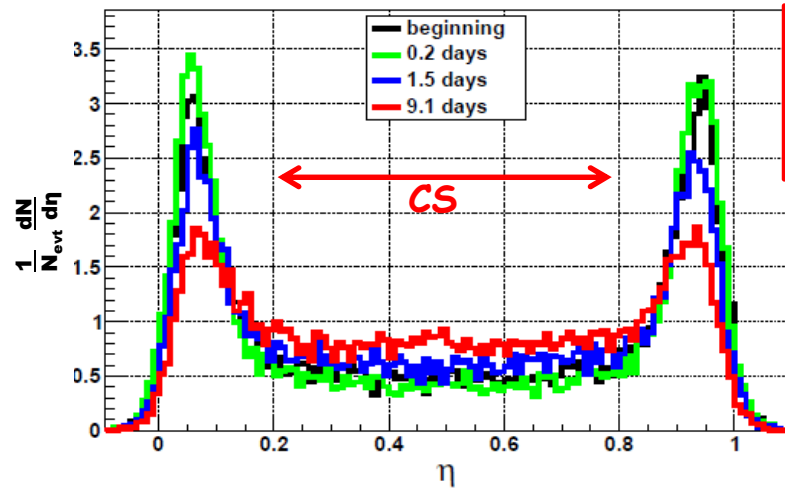


Change in seed distr. - events at $<0.5 \cdot mpv$!



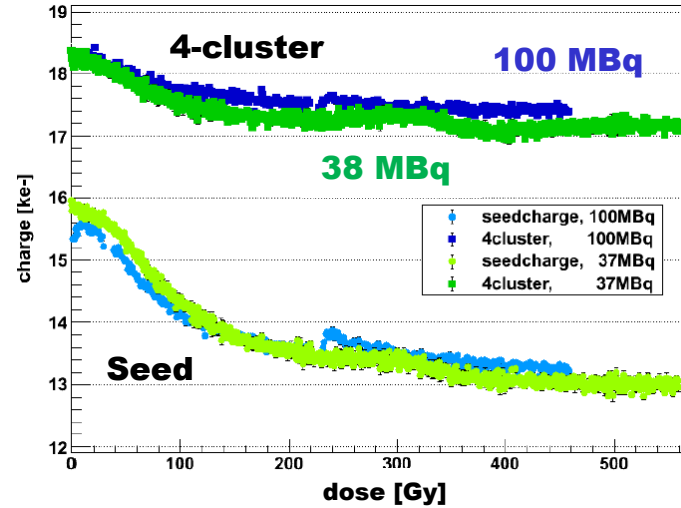
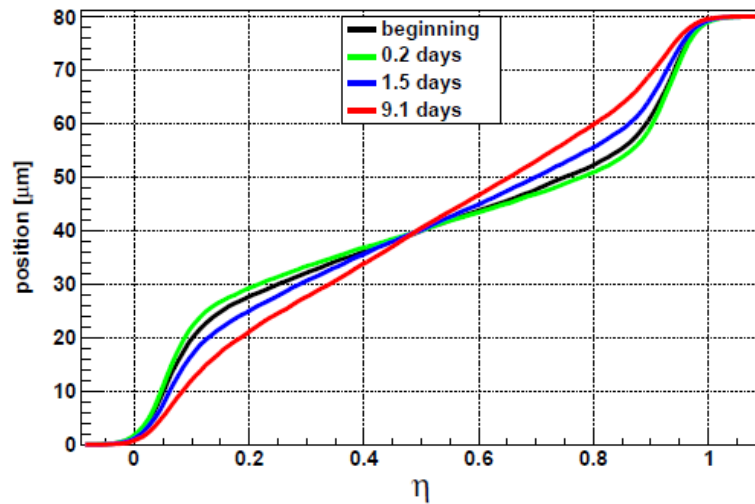
Effect only where sensor irradiated

Observations for $V_{bias} = 600$ V (non irr. p-stop sensor)



Significant increase in charge sharing

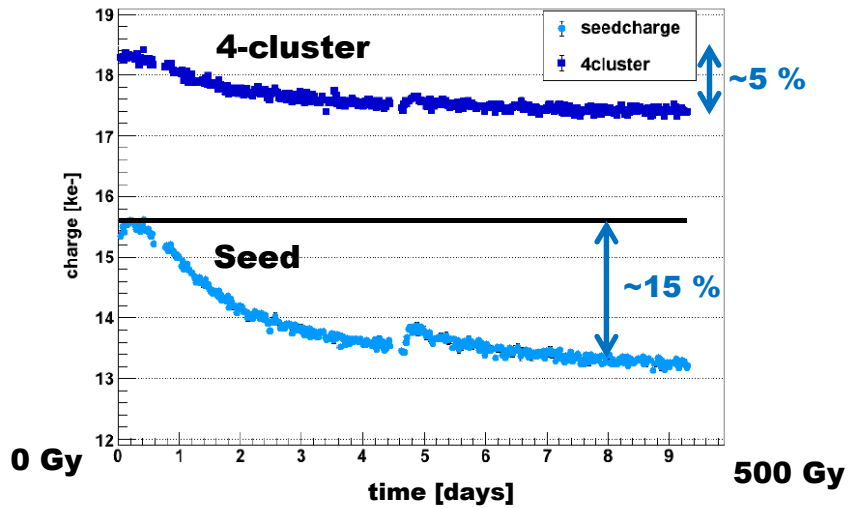
Increase in charge sharing



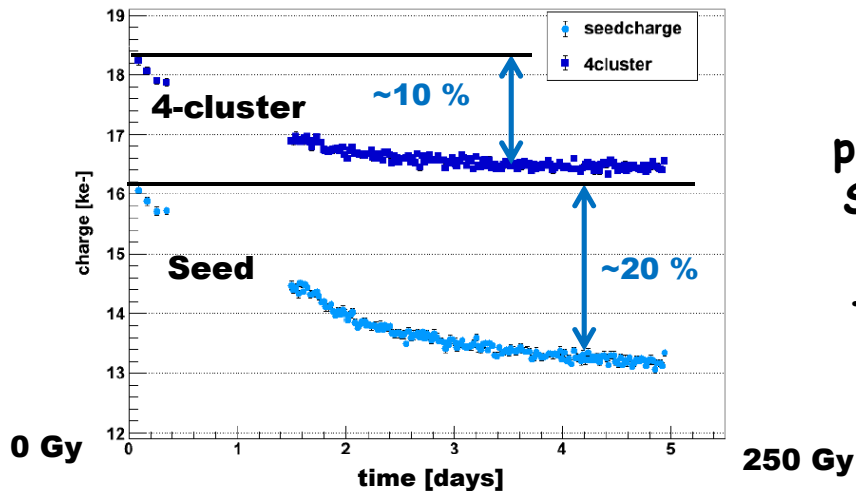
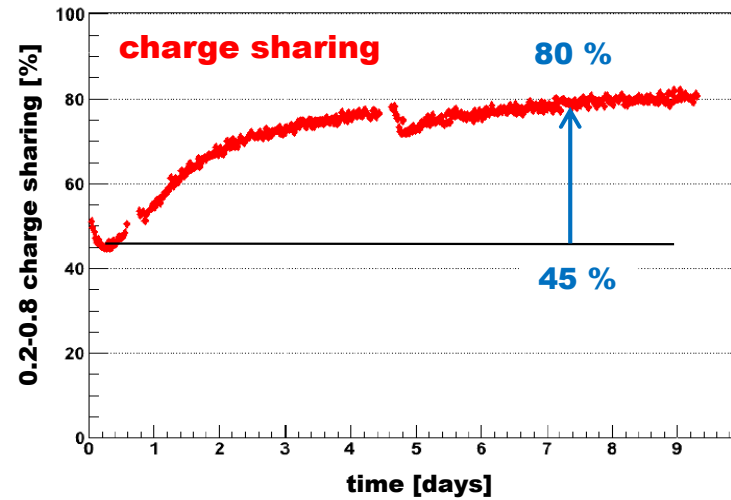
Change of η vs. position relation

Change depends on dose - not dose rate

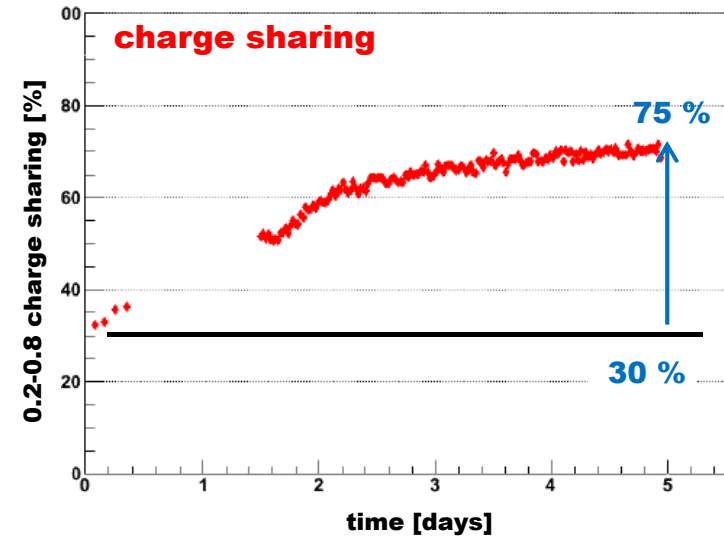
Comparison p-stop vs. p-spray (non-irradiated)



p-stop
Sensor
600 V
-20°C

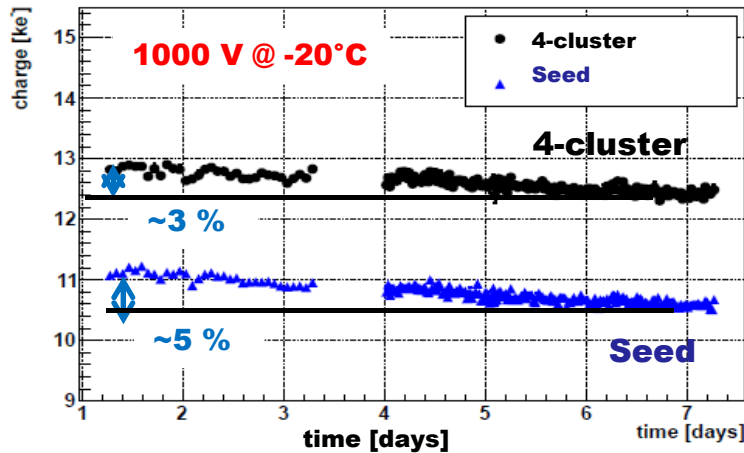


p-spray
Sensor
600 V
-20°C

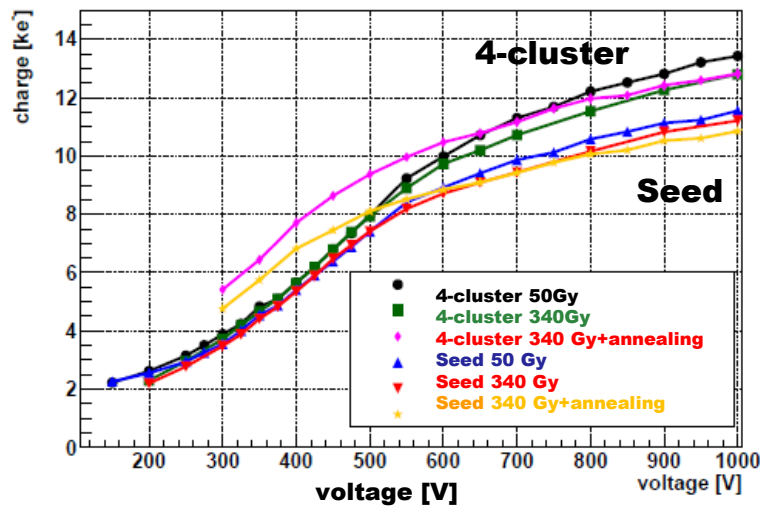


Effects bigger for p-spray than for p-stop sensor

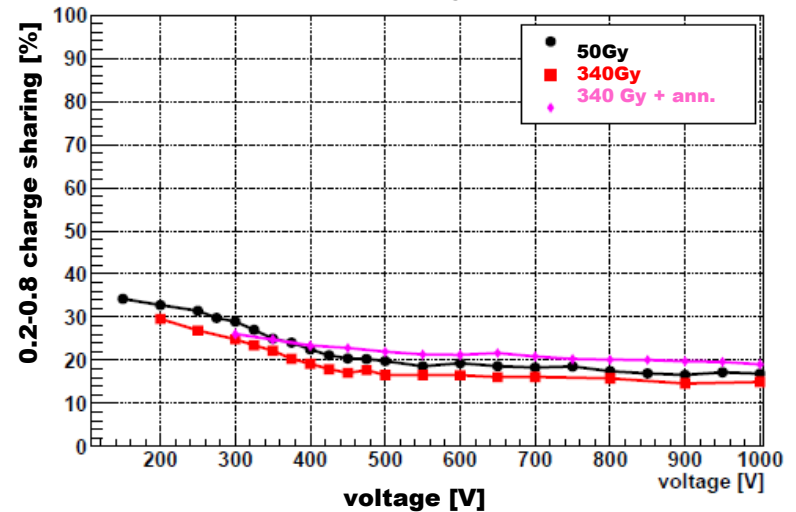
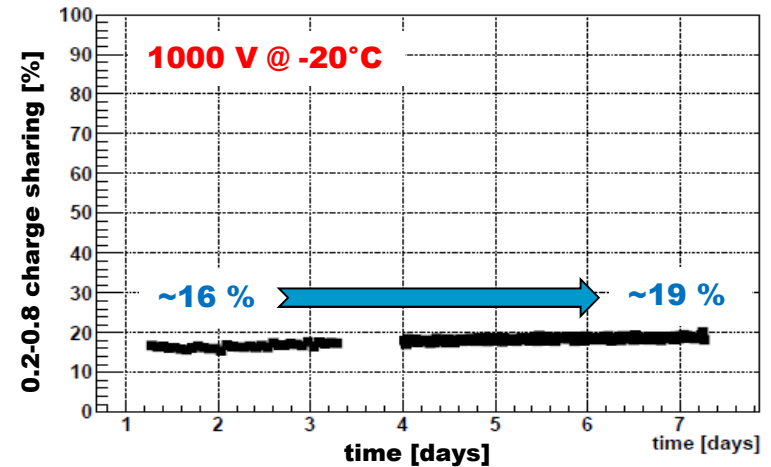
Irradiated (p-stop) sensor @ 1000 V



irradiated
 $15 \cdot 10^{14}$ GeV p
 $+6 \cdot 10^{14}$ n
 p-spray
 Sensor
 1000 V
 -20°C



annealing =
 12 h @ 80°C



Small effect for irradiated sensor at 1000 V
 + annealing has only a small effect

Summary of observations → surface damage

Low dose [O(kGy)] ionizing irradiation changes charge collection in n+p Si strip sensors: **Increase in charge sharing + increase in charge losses**

- Effect decreases with: **p-spray → p-stop → hadron irradiated sensor**

Suspected cause: Surface damage + charge build-up in/on insulators

Surface damage is complicated !!!

We will **only** consider build up of surface charges with density

$N_{ox}@doses < 1 \text{ kGy}^*)$:

$\text{few} \cdot 10^{10} \text{ cm}^{-2} < 100 >$

$\sim 10^{11} \text{ cm}^{-2} < 111 >$

$+ 4 \cdot 10^{11} \text{ cm}^{-2} \cdot D[\text{kGy}]$

and effects of surface boundary conditions

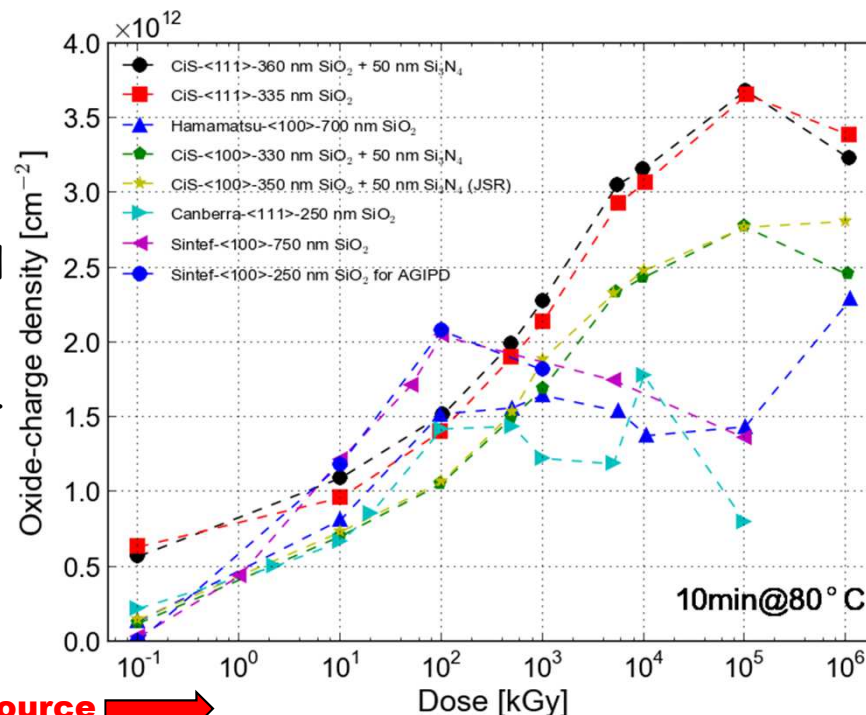
for more information see:

^{*)} J.Zhang et al., JSR 19 (2012) 340;

J. Schwandt et al., arXiv-140213;

T.Poehlsen et al., NIM-A 721 (2013) 26.

$Nox [10^{12} \text{ cm}^{-2}]$
for different
producers,
crystal orient.
 d_{ox} , etc.



β-source →

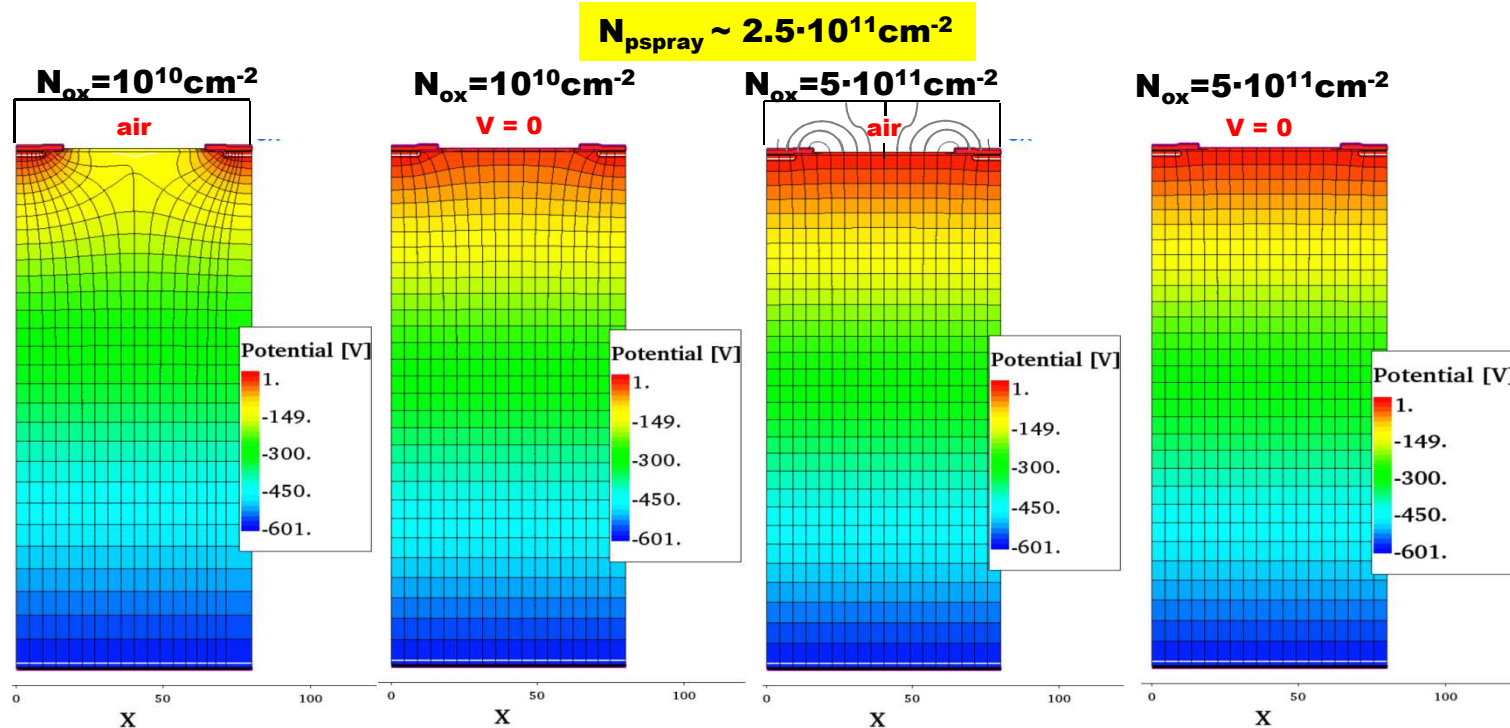
HL-LHC →

XFEL →

Synopsys TCAD simulation of p-spray sensor vs. N_{ox}

Results on simulations depend also on boundary conditions:

1. "Dirichlet": SiO_2 surface on potential of readout strips (0 V)
2. "Air": 500 μm above strips Dirichlet with potential of readout strips



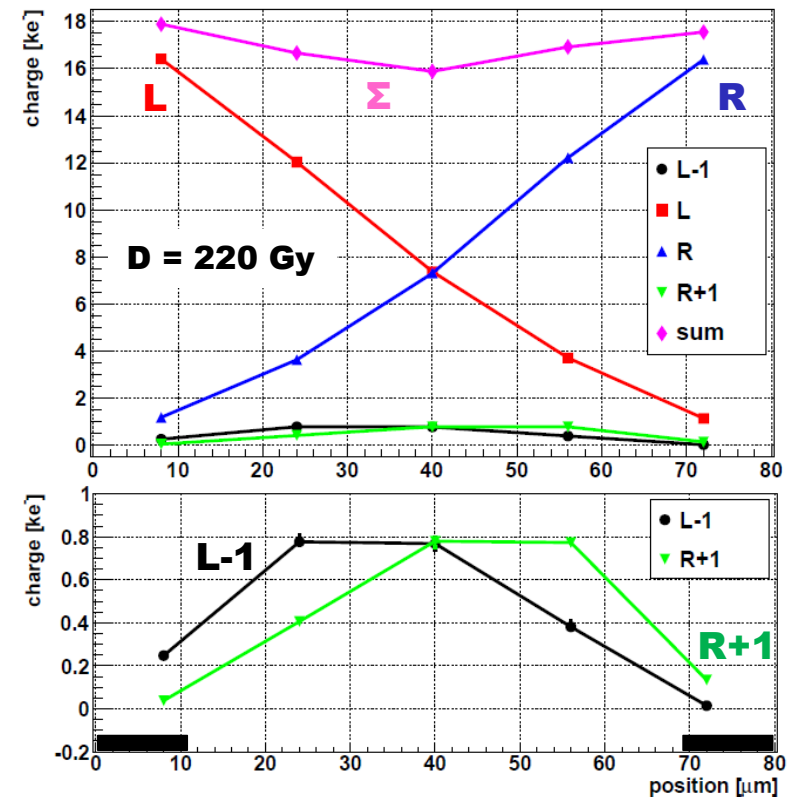
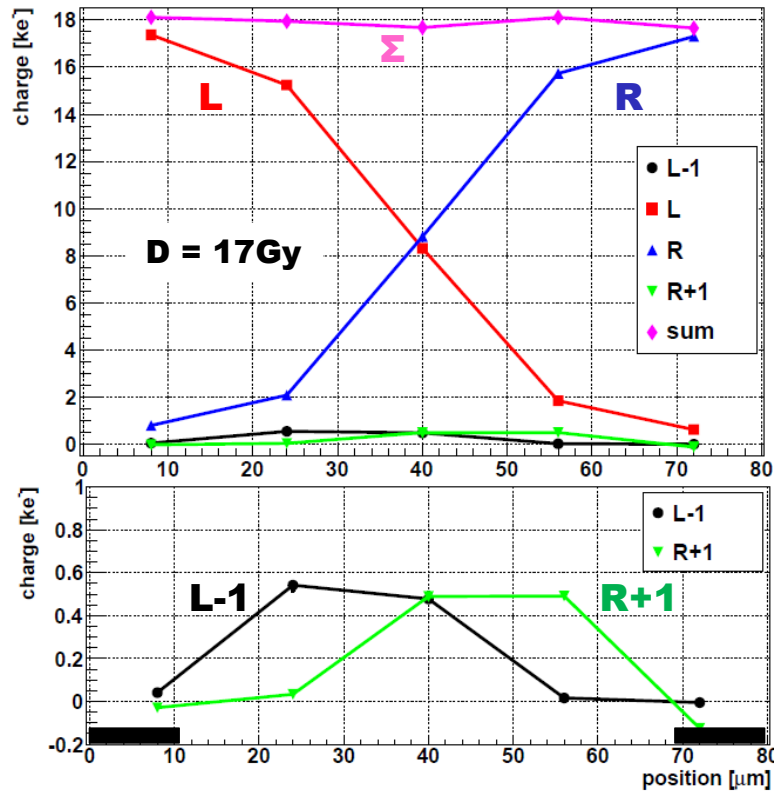
$N_{ox} < N_{p-spray}$: E-field lines end at readout strips \rightarrow no charge sharing

$N_{ox} > N_{p-spray}$: E-field lines end at Si-SiO₂ interface \rightarrow charge sharing

Increase of oxide charge density $N_{ox} \rightarrow$ Change of charge sharing

Charge sharing and charge losses

Using the η - x transformation we can study pulse-heights vs. position



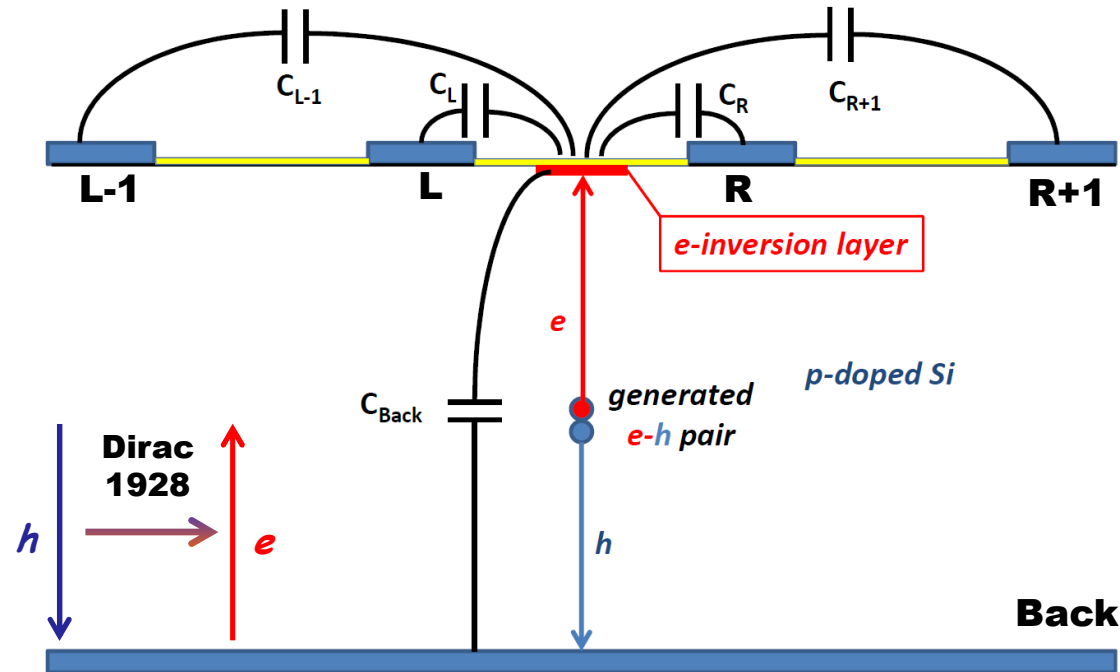
Increasing dose:

- increased charge sharing
- increased charge losses
- increase of signal in L-1 and R+1 strips

Charge sharing versus charge losses

Explained with **weighting fields** taking charge layers^{*)} into account !

(^{*)} with dielectric relaxation time $T_{\text{charge layer}} < \text{charge collection time}$



C_i ... depend on position where e gets stuck

$$C_{\text{tot}} = \sum C_i$$

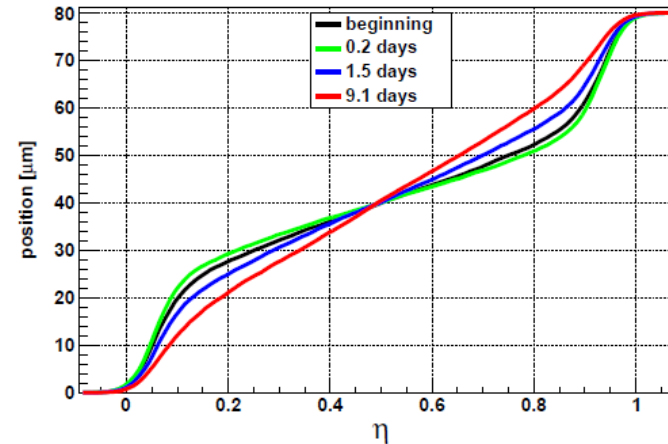
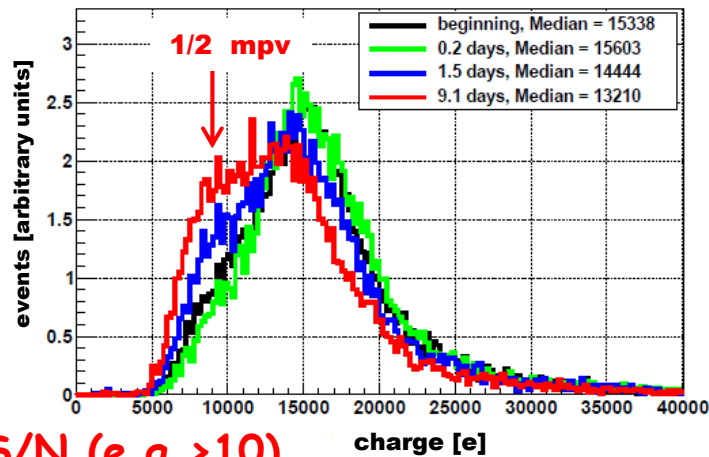
$$\text{Signal}_i = q \cdot (C_i / C_{\text{tot}}) = q \cdot [C_i / \sum (C_{\text{strips}} + C_{\text{back}})]$$

C_{back} determines the charge losses ($C_{\text{back}} = 0 \rightarrow \text{no losses}$)

Relevance for sensor design

Impact depends on S/N, readout scheme, track angle, dose, etc.

Here only qualitative discussion - needs quantitative estimation for a specific design



Good S/N (e.g. >10)

- analog readout: Charge Sharing improves the position resolution ($\delta \sim 1/(dx/dn)$) 😊
- binary readout: CS improves the resolution and worsens the track separation 😞

Poor S/N (e.g. <10)

- analog readout: as long as low signal pulses are read out, CS improves the position resolution 😊
- binary readout: unless low threshold, loss in efficiency; threshold $< 0.4 \cdot mpv$
 \rightarrow for 3σ noise cut $S(\text{cluster})/N > 7.5$ required 😞



Charge Sharing important for design of efficient sensor -
of similar importance as Charge Collection Efficiency



Conclusions

- Low-dose ionizing radiation changes oxide (+interface) charges
 - for n⁺p segmented sensors change of charge collection:
charge losses, charge sharing, signals in next-to-next strips
- Impact depends on track angle, signal/noise (S/N), readout
 - **good S/N**: resolution improves @ small angles
 - **poor S/N**: efficiency decreases drastically
 - effective threshold < 0.4 mpv → 3σ noise cut = S/N > 7.5 !**
- Oxide (+other dielectrics) damages have to be taken into account in sensor design (+ sensor simulations)
 - for n⁺p **probably N(p-spray/stop) > few 10¹²cm⁻²** and broader n⁺-implants if charge sharing should be minimized
 - in addition impact on breakdown voltage + guard ring design to be considered

More work needed on understanding of charge build-up in dielectrics and interfaces (e.g. dependence on E-field, annealing, technology) and how to implement this information in realistic sensor simulations

References to Work from UHH-Group



If you did not like this talk, you will also not like the following publications (free translation from V. von Bülow "Loriot")

Wenn Sie das vorliegende Buch un-
gern gelesen haben, werden Ihnen
diese auch nicht so recht gefallen.

V. von Bülow "Loriot"

AGIPD:

AGIPD (Adaptive Gain Integrating Pixel Detector) http://photon-science.desy.de/research/technical_groups/detectors/projects/agipd/

B. Henrich et al., The adaptive gain integrating pixel detector AGIPD a detector for the European XFEL, NIM-A 6333 Supp.(2011)S11; doi:10.1016/j.nima.2010.06.107

Low-dose effects in segmented Si sensors:

C. Henkel, Impact of low dose-rate electron irradiation on the charge collection of n+p silicon strip sensors, [BSC thesis, University of Hamburg](#), March 2014, unpublished

J. Erfle Irradiation study of different silicon materials for the CMS tracker upgrade, [PhD thesis, University of Hamburg](#), April 2014, unpublished

Charge trapping at the Si-SiO₂ interface:

T. Poehlsen et al., Study of the accumulation layer and charge losses at the Si-SiO₂ interface in p+n-silicon strip sensors, NIM-A 721 (2013) 26; doi: 10.1016/j.nima.2013.04.026

T. Poehlsen et al., Time dependence of charge losses at the Si-SiO₂ interface in p+n-silicon strip sensors, in press NIM-A; doi: 10.1016/j.nima.2013.03.035

T. Poehlsen, Charge Losses in Silicon Sensors and Electric-Field Studies at the Si-SiO₂ Interface, [PhD thesis, University of Hamburg](#), DESY-Thesis-2013-025 (2013)

X-ray radiation damage:

J. Zhang et al., Study of radiation damage induced by 12 keV X-rays in MOS structures built on high-resistivity n-type silicon, J. Synchrotron Rad. 19 (2012) 340; doi: 10.1107/S0909049512002384

R. Klanner et al., Study of high-dose X-ray radiation damage of silicon sensors, in press NIM-A; doi: 10.1016/j.nima.2013.05.131

J. Zhang et al., X-ray induced radiation damage in segmented p+n silicon sensors, PoS (Vertex 2012) 019

J. Zhang, X-ray Radiation Damage Studies and Design of a Silicon Pixel Sensor for Science at the XFEL, [PhD thesis, University of Hamburg](#), DESY-THESIS-2013-018 (2013)

Sensor optimization for high X-ray dose :

J. Schwandt et al., Optimization of the radiation hardness of silicon pixel sensors for high x-ray doses using TCAD simulations, 2012 JINST 7 C01006; doi: 10.1088/1748-0221/7/01/C01006

J. Schwandt et al., Design of the AGIPD sensor for the European XFEL, 2013 JINST 8 C01015; doi: 10.1088/1748-0221/8/01/C01015

J. Schwandt et al., Design and First Tests of a Radiation-Hard Pixel Sensor for the European X-Ray Free-Electron Laser, accepted for publication in IEEE TNS, arXiv-140213

J. Schwandt, Design of a radiation hard pixels sensor for X-ray science, [PhD thesis, University of Hamburg](#), May 2014, unpublished